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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/820,575
Filing Date April 7, 2004
Inventor Scott E. Moore et al.
Assignee Micron Technology, Inc.
Group Art Unit 2877
Examiner Roy Punnoose
Attorney's Docket No. MI22-2493
Title: Semiconductor Workpiece Processing Methods and Turbidity Monitoring Methods

RESPONSE TO APRIL 21, 2005 OFFICE ACTION

To: Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

From: James D. Shaurette (Tel. 509-624-4276; Fax 509-838-3424)
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Sir:

This is a response to the Office Action dated April 21, 2005, Applicants amend and
remark as follows:

AMENDMENTS

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